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Neutral gas flow effect in a large area CCP plasma source
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/ NewYork University — We modified XPDP2 code to include neutral gas flow effect
on CCP discharge for argon gas. Parallelized multi-grid method is used for efficient
field calculation. Particle simulation is used for gas flow calculation and spatially
non uniform gas distribution is obtained. Ionization, charge exchange and neutral
- neutral collision effect are considered for realistic neutral gas simulation. Multi-
time scale simulation is used to get steady state discharge including gas depletion
by ionization. Preliminary results are obtained and compared with the results from
uniform background neutral gas distribution.

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